# PATENT ASSIGNMENT COVER SHEET

Electronic Version v1.1 Stylesheet Version v1.2 EPAS ID: PAT3157958

SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT

#### **CONVEYING PARTY DATA**

Name	Execution Date
ANTON ROZEN	08/16/2012
ROY DRUCKER	11/20/2012
LEONID SMOLYANSKY	08/15/2012

### **RECEIVING PARTY DATA**

Name: FREESCALE SEMICONDUCTOR INC.	
Street Address:	6501 WILLIAM CANNON DRIVE WEST
City:	AUSTIN
State/Country:	TEXAS
Postal Code:	78735

### **PROPERTY NUMBERS Total: 1**

Property Type	Number
Application Number:	14410146

### **CORRESPONDENCE DATA**

**Fax Number:** (512)895-6630

Correspondence will be sent to the e-mail address first; if that is unsuccessful, it will be sent

using a fax number, if provided; if that is unsuccessful, it will be sent via US Mail.

**Phone:** 512-895-6979

Email: USADOCKETING@FREESCALE.COM

Correspondent Name: FREESCALE SEMICONDUCTOR, INC. LAW DEPART Address Line 1: 6501 WILLIAM CANNON DRIVE WEST TX30/OE62

Address Line 4: AUSTIN, TEXAS 78735

ATTORNEY DOCKET NUMBER: NM46157EH	
NAME OF SUBMITTER:	ROSEMARY HOFFERT
SIGNATURE:	/ROSEMARY HOFFERT/
DATE SIGNED:	12/22/2014

## **Total Attachments: 13**

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## ASSIGNMENT AND AGREEMENT

For good and valuable consideration, the receipt of which is hereby acknowledged, we. rozen anton, gedera, israel, druker roy, Rishon Le Zion, israel and smolyansky leonid, Zichron Yukov, israel have sold, assigned and transferred, and do hereby sell, assign and transfer, unto FREESCALE SEMICONDUCTOR. INC., a corporation of the State of Delaware, having its principal office in Austin. Texas. United States of America, and their successors, assigns, and legal representatives, the entire right, title and interest for the United States of America, in and to certain inventions relating to improvements in METHOD AND APPARATUS FOR MANAGING A THERMAL BUDGET OF AT LEAST A PART OF A PROCESSING SYSTEM (Docket No. NM46157EH), described, illustrated and claimed in an application for Letters Patent of the United States of America executed by us on the dates indicated by our signatures below, together with the entire right, title and interest in and to the application, and in and to Letters Patent which may be issued upon the application, and upon any division, extension, continuation or reissue thereof.

We hereby also sell, assign and transfer unto FREESCALE SEMICONDUCTOR, INC., the entire right, title and interest in and to the invention and in and to applications for Letters Patent therefor in all countries foreign to the United States of America, including all rights under any and all international conventions and treaties in respect of the invention and the applications for Letters Patent in foreign countries, and we further authorize FREESCALE SEMICONDUCTOR, INC. to apply for Letters Patent in foreign countries directly in its own name, and to claim priority of the filing date of the application for Letters Patent of the United States of America under the provisions of any and all international conventions and treaties.

We hereby authorize and request the Commissioner of Patents of the United States of America to issue Letters Patent upon the aforesaid application, division, extension, continuation or reissue, to FREESCALE SEMICONDUCTOR, INC. for the sole use and benefit of FREESCALE SEMICONDUCTOR, INC. their successors, assigns and legal representatives, to the full end of the term for which Letters Patent may be granted, the same as they would have been held and enjoyed by me had this assignment not been made, and we hereby authorize and request the equivalent authorities in foreign countries to issue the patents of their respective countries to FREESCALE SEMICONDUCTOR, INC.

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We agree that, when requested, we will, without charge to FREESCALE SEMICONDUCTOR, INC. but at its expense, sign all papers, take all rightful oaths, and do all acts which may be necessary, desirable or convenient for securing and maintaining patents for the inventions in any and all countries and for vesting title thereto in FREESCALE SEMICONDUCTOR, INC. their successors, assigns and legal representatives or nominees.

We covenant with FREESCALE SEMICONDUCTOR, INC., their successors, assigns and legal representatives, that the interest and property hereby conveyed is free from all prior assignment, grant, mortgage, license or other encumbrance.

rozen anton	DATE: Aug 16 2012
First Witness	
SIGNATURE OF WITNESS	DATE: Aug 16 2012 (Month-Day-Year)
I ring Roten PRINTED NAME OF WITNESS	

SIGNATURE OF WITNESS  DATE: Aug 16 2012  (Month-Day/Year)	Second Witness	
(Month Day-Year)	, -	DATE: Aug 16 2012 (Month-Day-Year)

Leonid Shmuilouich	
PRINTED NAME OF WITNESS	·

	The state of the s
druker roy	DATE:
First Witness	
SIGNATURE OF WITNESS	DATE: (Month-Day-Year)
PRINTED NAME OF WITNESS	
Second Witness	
SIGNATURE OF WITNESS	DATE:  ' (Month-Day-Year)
	,

PRINTED NAME OF WITNESS

smolyansky leonid	DATE:
First Witness	
SIGNATURE OF WITNESS	DATE: (Month-Day-Year)
PRINTED NAME OF WITNESS	
Second Witness	
SIGNATURE OF WITNESS	DATE: (Month-Day-Year)
PRINTED NAME OF WITNESS	

#### ASSIGNMENT AND AGREEMENT

For good and valuable consideration, the receipt of which is hereby acknowledged, we, ROZEN ANTON, GEDERA, ISRAEL, DRUKER ROY, RISHON LE ZION, ISRAEL and SMOLYANSKY LEONID, ZICHRON YAKOV, ISRAEL have sold, assigned and transferred, and do hereby sell, assign and transfer, unto FREESCALE SEMICONDUCTOR, INC., a corporation of the State of Delaware, having its principal office in Austin, Texas, United States of America, and their successors, assigns, and legal representatives, the entire right, title and interest for the United States of America, in and to certain inventions relating to improvements in METHOD AND APPARATUS FOR MANAGING A THERMAL BUDGET OF AT LEAST A PART OF A PROCESSING SYSTEM (Docket No. NM46157EH), described, illustrated and claimed in an application for Letters Patent of the United States of America executed by us on the dates indicated by our signatures below, together with the entire right, title and interest in and to the application, and in and to Letters Patent which may be issued upon the application, and upon any division, extension, continuation or reissue thereof.

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We hereby authorize and request the Commissioner of Patents of the United States of America to issue Letters Patent upon the aforesaid application, division, extension, continuation or reissue, to FREESCALE SEMICONDUCTOR, INC. for the sole use and benefit of FREESCALE SEMICONDUCTOR, INC. their successors, assigns and legal representatives, to the full end of the term for which Letters Patent may be granted, the same as they would have been held and enjoyed by me had this assignment not been made, and we hereby authorize and request the equivalent authorities in foreign countries to issue the patents of their respective countries to FREESCALE SEMICONDUCTOR, INC.

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and legal representatives, that the interest and property hereby conveyed is free from all prior assignment, grant, mortgage, license or other encumbrance. DATE: ROZEN ANTON First Witness DATE: (Month-Day-Year) SIGNATURE OF WITNESS PRINTED NAME OF WITNESS Second Witness DATE: (Month-Day-Year) SIGNATURE OF WITNESS PRINTED NAME OF WITNESS

We covenant with FREESCALE SEMICONDUCTOR, INC., their successors, assigns

DRUKER ROY	DATE: <u>44/Q0/Q04Q</u>
First Witness	DATE: /// DO/ 2012 (Month-Day-Year)
AVIKAM SHAVIT PRINTED NAME OF WITNESS	
Second Witness  SIGNATURE OF WITNESS	DATE: <u>// 20/2 a/2</u> (Month-Day-Year)
OOV BERGER PRINTED NAME OF WITNESS	

SMOLYANSKY LEONID	DATE:
First Witness	
SIGNATURE OF WITNESS	DATE:(Month-Day-Year)
PRINTED NAME OF WITNESS	
Second Witness	
SIGNATURE OF WITNESS	DATE:(Month-Day-Year)
PRINTED NAME OF WITNESS	

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For good and valuable consideration, the receipt of which is hereby acknowledged, we, ROZEN ANTON, GEDERA, ISRAEL, DRUKER ROY, RISHON LE ZION, ISRAEL and SMOLYANSKY LEONID, ZICHRON YAKOV, ISRAEL have sold, assigned and transferred, and do hereby sell, assign and transfer, unto FREESCALE SEMICONDUCTOR, INC., a corporation of the State of Delaware, having its principal office in Austin, Texas, United States of America, and their successors, assigns, and legal representatives, the entire right, title and interest for the United States of America, in and to certain inventions relating to improvements in METHOD AND APPARATUS FOR MANAGING A THERMAL BUDGET OF AT LEAST A PART OF A PROCESSING SYSTEM (Docket No. NM46157EH), described, illustrated and claimed in an application for Letters Patent of the United States of America executed by us on the dates indicated by our signatures below, together with the entire right, title and interest in and to the application, and in and to Letters Patent which may be issued upon the application, and upon any division, extension, continuation or reissue thereof.

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ROZEN ANTON	DATE:	
First Witness		
SIGNATURE OF WITNESS	DATE:	(Month-Day-Year)
PRINTED NAME OF WITNESS		
Second Witness		
SIGNATURE OF WITNESS	DATE:	(Month-Day-Year)
PRINTED NAME OF WITNESS		

We covenant with FREESCALE SEMICONDUCTOR, INC., their successors, assigns

and legal representatives, that the interest and property hereby conveyed is free from all prior

assignment, grant, mortgage, license or other encumbrance.

DRUKER ROY	DATE:
First Witness	
SIGNATURE OF WITNESS	DATE:(Month-Day-Year)
PRINTED NAME OF WITNESS	
Second Witness	
SIGNATURE OF WITNESS	DATE:(Month-Day-Year)
PRINTED NAME OF WITNESS	

re: <u>08-75-2072</u> (Month-Day-Year)
TE:(Month-Day-Year)